Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	Applicant(s)/Patent under Reexamination	
10/785,200	HAUVILLE, FRANCOIS P.		
Examiner	Art Unit		
Krishnan S. Menon	1723		

SEARCHED					
Class	Subclass	Date	Examiner		
210	235,346 323.1 335,435 446	10/20/2006	КМ		
55	315,318				
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
Inventor Search	2/3/2006	YK
See EAST Search History 210/232,323.1,323.2,423,253,321.75	2/6/2006	YK
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